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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Shun-ichi FUKUYAMA et al.

Group Art Unit: 2813

Serial No.: 10/630,716

Examiner: Stephen W. Smoot

Filed: July 31, 2003

Confirmation No.: 9374

For: SEMICONDUCTOR DEVICE USING LOW-K MATERIAL AS
INTERLAYER INSULATING FILM AND ITS MANUFACTURE
METHOD

Attorney Docket Number: 030860

Customer Number: 38834

RESPONSE AFTER FINAL

Box AF

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Date: April 20, 2005

Sir:

This paper is filed in response to the Office Action dated February 11, 2005.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 8 of this paper.

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